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Bib Data Sheet

CONFIRMATION NO. 1672

SERIAL NUMBER 10/085,725	FILING DATE 02/28/2002 RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. TI-31621
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APPLICANTS

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** CONTINUING DATA ***** *MK (none)*

** FOREIGN APPLICATIONS ***** *MK (verified)*
 JAPAN 13(2001)-59777 03/05/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 03/25/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Signature</i> Examiner's Signature	STATE OR COUNTRY JAPAN	SHEETS DRAWING 2	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 2
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Verified and Acknowledged

INITIALS *MK*

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 23494
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TITLE
 Method and device for removing particles on semiconductor wafers

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